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6/15/04

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

RE APPLICATION OF

SHIGENOBU MAEDA

: EXAMINER: LEBENTRITT, M.

SERIAL NO: 09/761,738

: APPEAL NO: 2003-1310

FILED: JANUARY 18, 2001

: GROUP ART UNIT: 2824

FOR: MANUFACTURING METHOD OF SEMICONDUCTOR WAFER,
SEMICONDUCTOR MANUFACTURNG APPARATUS, AND
SEMICONDUCTOR DEVICE

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Official Action dated February 21, 2002 and the Decision on Appeal and Order mailed February 19, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.

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